

# 2016 Source Workshop

## Keynote Presenter

### Stefan Witte

Stefan Witte received his PhD in 2007 from the Vrije Universiteit Amsterdam, for work on intense ultrafast laser development and precision spectroscopy. He did postdoctoral work at on nonlinear microscopy and biomedical imaging (Vrije Universiteit) and on ultrafast electron dynamics and lensless imaging with high-harmonic sources (JILA, University of Colorado).

Since 2014 he is a group leader in the EUV Generation and Imaging group at the Advanced Research Center for Nanolithography (ARCNL) and assistant professor at the Vrije Universiteit Amsterdam. His present research interests include coherent diffractive imaging with visible and EUV radiation, high-harmonic generation and its applications, and advanced laser development for plasma experiments.



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